

L

NEMS/MEMS Technology and Devices



ICMAT 2009



IUMRS - ICA 2009

International Conference on Materials for Advanced Technologies 2009

AND

International Union of Materials Research Societies- International Conference in Asia 2009



**28 June - 3 July 2009, Singapore
Suntec Singapore International Convention & Exhibition Centre**

www.mrs.org.sg

Organised by



In association with



Institute of
Materials Research
and Engineering



NANYANG
TECHNOLOGICAL
UNIVERSITY

Symposium L

NEMS/MEMS Technology and Devices

Chairs

Ai-Qun LIU, *Nanyang Technological University, Singapore*
Tarik BOUROUINA, *ESIEE, France*

Co-Chairs

Vincent Chengkuo LEE, *National University of Singapore, Singapore*
Hua LI, *Nanyang Technological University, Singapore*
Gwo-Bin LEE, *National Cheng Kung University, Taiwan*
Franck CHOLLET, *Universite de Franche Comte, France*

Correspondence

Ai-Qun LIU
Nanyang Technological University
School of Electrical & Electronic Engineering
50 Nanyang Avenue
Singapore 639798
Email: eaqliu@ntu.edu.sg
Tel: (65) 67904336
Fax: (65) 67933318

Scope of Symposium

The emphasis of this symposium is on Nanoelectromechanical Systems (NEMS)/Microelectromechanical Systems (MEMS) technology and devices. Particularly applications that involve MEMS design, modeling, fabrication processes (e.g. semiconductors, polymers, etc.) lab-on-a-chip, and biophotonic medical devices (e.g. DNA, protein and cell sorting, etc.) are preferred. This symposium will explore new devices and processes innovation and engineering applications, especially related to NEMS/MEMS technology and devices.

Symposium Topics

- Theory, Design, Analysis of MEMS and NEMS
- Materials and Device Characterization
- Fabrication Technologies
- Packaging and Assembly Technology
- Mechanical and Physical Sensors
- Chemical Sensors and Microsystems
- BioMEMS and Fluidic Systems
- Actuators and micro-structure modeling
- Optical MEMS and nanophotonic (PBG, QD and plasmonics)
- RF MEMS devices and switching circuits
- Sensing System, Algorithm and Sensor Networks
- Nanotechnology and NEMS Devices
- Lab-on-a-chip and uTAS devices
- Plasmonic MEMS and devices

Contents

| | | |
|--------------|---|----|
| A00017-00479 | Design and Analysis of Micromixers on a Centrifugal Platform <i>Chih-Hsin SHIH; Chia-Hui LIN; Hou-Jin WU</i> | 9 |
| A00017-00538 | Supernatant Decanting on a Centrifugal Platform <i>Chih-Hsin SHIH; Wei-Ling CHIANG</i> | 9 |
| A00041-00064 | Fiber-top Micromachined Devices: Ideas on the Tip of Fiber <i>Davide IANNUZZI</i> | 9 |
| A00045-01976 | A MEMS Pendulum-like Structure for Design of Oscillators <i>Venkatesh CHENNIAPPAN; Reza MOHEIMANI; Mehmet YUCE</i> | 10 |
| A00079-02927 | Electrophoretic Coulter Method for Analyzing Surface Properties of Particles Using a Micro-fluidic Device <i>Naohiro TAKAHASHI; Atushi AKI; Tomofumi UKAI; Yoshikata NAKAJIMA; Tatsuro HANAJIRI; Toru MAEKAWA</i> | 10 |
| A00123-00735 | Design and Characterization of a Fourier Transform Micro-spectrometer <i>Shouhua WANG; Hongbin YU; Fook Siong CHAU; Xiaosong TANG</i> | 11 |
| A00131-00287 | Microstructure and Magnetic Properties of Rapidly Solidified Ni ₂ (Mn,Fe)Ga Heusler Alloys <i>Venkata Satya Prasad RAGHUPATRUNI; Raja MANIVEL; Phanikumar GANDHAM</i> | 11 |
| A00170-02217 | Nano-photonic & Electronic Structures Pattern and Fabrication <i>Selin H. G. TEO; Guo Qiang LO; Navab SINGH; Mingbin YU; Ai Qun LIU</i> | 12 |
| A00182-01985 | Separation and Manipulation of Particles using Traveling Wave Dielectrophoretic Force <i>Thitima MATUROS; Kata JARUWONGRANGSEE; Assawapong SAPPAT; Anurat WISITSORAAT; Tanom LOMAS; Pkul WANICHAPICHART; Adisorn TUANTRANONT</i> | 12 |
| A00185-00382 | Performance Characterization of a Piezoelectric Micro SJA <i>An-Shik YANG; Jeng-Jong RO; Wei-Han CHANG</i> | 12 |
| A00185-00384 | Mixing Enhancement of a Passive Micromixer by Applying Boundary Protrusion Structures <i>Chang-Yu HSIEH; An-Shik YANG</i> | 13 |
| A00186-00475 | Use of Micro Synthetic Jet Actuators for Boundary Layer Flow Control <i>Jing-Chuen LIN; An-Shik YANG; Li-Yu TSENG</i> | 13 |
| A00186-00544 | A Novel Piezoelectric Valveless Micropump with an Integrated Diffuser/Nozzle Bulge Piece Design <i>Tsung-Hsing CHAN; Chiang-Ho CHENG; An-Shik YANG; Li-Yu TSENG</i> | 14 |
| A00201-02560 | Kelvin Force Microscope Immunoassay for Electrical Label-free Characterization <i>Shinkichi NUMATA; Shigeru YAMASITA; Atsushi AKI; Atsumu SHOJI; Toru MIZUKI; Yoshikata NAKAJIMA; Toru MAEKAWA; Tatsuro HANAJIRI</i> | 14 |
| A00214-01808 | Design and Characterization of a MEMS-microfluidic Sensor for Rheological Applications <i>Helene BERTHET; Howard STONE; Frédéric MARTY; Bruno MERCIER; Jacques JUNDT; Dan ANGELESCU</i> | 15 |
| A00297-00734 | Gas Bubble Sizes Formed in Liquids at Different Resonant Frequencies <i>Chiang-Ho CHENG; Li-Yu TSENG; Tsung-Hsing CHIANG</i> | 15 |
| A00306-00573 | Characterization and Optimization of Seal-Off for Very Low Pressure Sensors (VLPS) Fabricated by CMOS MEMS Process <i>Muhamad Ramdzan BUYONG; Norazreen ABD AZIZ</i> | 16 |
| A00335-00623 | Analysis of Ionic Transport Interaction between Soft Smart Hydrogel and Solution in BioMEMS Channels <i>Rongmo LUO; Hua LI; Teng Yong NG; Khin Yong LAM</i> | 16 |
| A00378-00696 | High Temperature Reliability Study of MEMS Capacitive Accelerometers <i>Nazman ZAIYADI</i> | 16 |
| A00387-00715 | Evolutionary Algorithm Based Feedforward Control for Contouring of a Biaxial Piezo-actuated Stage <i>Chih-Jer LIN; Shu-Yin CHEN</i> | 17 |

4 Symposium L - NEMS/MEMS Technology and Devices

| | | |
|--------------|--|----|
| A00392-00731 | Modeling of Cell Motion in Micro-scale Hydrodynamic-electrical Field <i>Ting YE; Hua LI; Khin Yong LAM</i> | 17 |
| A00405-00788 | A Continuum Theory for Simulation of Ionic-strength-sensitive Hydrogel for BioMEMS Application <i>Fukun LAI; Hua LI; Khin Yong LAM</i> | 17 |
| A00446-00836 | Microfluidic Sorting System Based on Optical Force Switching <i>Siew Kit HOI; Chammika UDALAGAMA; Chorng Haur SOW; Andrew A. BETTIOL</i> | 18 |
| A00507-00931 | A Transient Simulation for Analysis of Volume Transition of pH-sensitive Hydrogel in Micro-channel <i>Hua ZOU; Hua LI; Khin Yong LAM</i> | 18 |
| A00602-01100 | Novel Design and Fabrication of High Sensitivity MEMS Capacitive Sensor Array for Fingerprint Imaging <i>Mitra DAMGHANIAN; Burhanuddin YEOP MAJLIS</i> | 18 |
| A00602-02142 | Design and Analysis of Low-Power MEMS Speaker using Magnrtic Actuation Technology <i>Fatima Lina AYATOLLAHI; Burhanuddin YEOP MAJLIS</i> | 19 |
| A00604-01328 | Prediction of Burr Formation in Fabricating MEMS Components by Micro End Milling <i>Mohammad ALI; Nurul HAJAR; Aliff OMAR; Khairul IRMAN</i> | 19 |
| A00633-02258 | Parametric Study of Hot Embossing on Micro-holes <i>Cheng-Hsien WU; Ya-Zhen HU</i> | 20 |
| A00633-02308 | Closed-Die Compression Molding for Precision Optical Lenses <i>Cheng-Hsien WU; Siao-Yi LI; Chun-Yu LIU</i> | 20 |
| A00732-01296 | Analysis of Microelectromechanical Systems Using the Meshless Random Differential Quadrature Method <i>Shantanu MULAY; Hua LI; Khin Yong LAM</i> | 20 |
| A00736-01610 | Design and Fabricaiton of a MEMS-based Gas Sensor <i>Jin-Ho YOON; Jung-Sik KIM</i> | 21 |
| A00749-01325 | Fabrication of Reliable RF MEMS Switches in CPW Configuration <i>Jaibir SHARMA</i> | 21 |
| A00808-01418 | Exploring the Innovational Potential of Biomimetics for Novel 3D MEMS <i>Ille C. GEBESHUBER; Herbert STACHELBERGER; Burhanuddin Yeop MAJLIS</i> | 22 |
| A00858-01626 | Compatibility Study of Diamond-like Nanocomposite Thin Films with Hydrazine Propellant for MEMS Microthruster <i>Pijus KUNDU; Ashesh RAY CHAUDHURI; Soumen DAS; Tarun Kanti BHATTACHARYYA</i> | 22 |
| A00918-01611 | Modeling of Performance of Single Elastic Capsule in Time-dependent two-dimensional Micro Channel Flow <i>Gang MA; Hua LI; Teng Yong NG; Khin Yong LAM</i> | 23 |
| A00922-01616 | Parametric Study of Femtosecond Pulses Laser Hole Drilling of Silicon Wafer <i>Li Shi JIAO; Eddie Yin Kwee NG; Lee Mein WEE; Hong Yu ZHENG</i> | 23 |
| A01059-01839 | A Chip-level Disposable Optofluidic Device For Biosensing <i>Hong LIU; Nan ZHANG; Zi Chao SHIAH; Donna Xiao Dong ZHOU</i> | 23 |
| A01092-01899 | Process Development of Sealing for Very Low Pressure Sensor <i>Muhamad Ramdzan BUYONG; Norazreen ABD. AZIZ; Burhanuddin YEOP MAJLIS</i> | 24 |
| A01092-01907 | Process Characterization of Wet Etching for High Aspect Ratio Microneedles Development <i>Norazreen ABD. AZIZ; Muhamad Ramdzan BUYONG; Burhanuddin YEOP MAJLIS</i> | 24 |
| A01120-01995 | Mathematical Modeling of Hydrogels for Microfluidic Flow Control <i>Jundika Candra KURNIA; Erik BIRGERSSON; Arun Sadashiv MUJUMDAR; Lee Ching QUAH</i> | 24 |
| A01149-02731 | Silicide Thin Films for Silicon Micro-Machining: Masking and Structural Layers <i>Madhu BHASKARAN; Sharath SRIRAM</i> | 25 |
| A01216-02074 | Piezoelectric Micro-pump for Drug Delivery System Fabricated Using Two Optical Masks <i>Juliana JOHARI; Jumril YUNAS; Burhanuddin YEOP MAJLIS</i> | 25 |
| A01231-04699 | NanoPlasmonic Sensor <i>Eng Huat KHOO; Erping LI</i> | 26 |

| | | |
|--------------|--|----|
| A01232-02113 | Hybrid Simulation Approach on MEMS Piezoresistive Microcantilever-based Sensor for Biosensing Applications <i>Rosminazuin AB. RAHIM; Badariah BAIS; Burhanuddin YEOP MAJLIS</i> | 26 |
| A01232-02121 | Fabrication of Glucose Sensitive Actuator for DDS Microvalve <i>Nur Azrina DZULKEFLI; Masoomeh TEHRANIROKH; Badariah BAIS; Burhanuddin YEOP MAJLIS</i> | 27 |
| A01245-02147 | Investigation of Sidewall Roughness of High-Aspect-Ratio Microstructures Manufactured via Synchrotron Deep X-ray Lithography Using Proton Beam Patterned Masks <i>Yaping REN; Herbert O. MOSER; Weisheng YUE; Thomas OSIPOWICZ; Francis, Eng Hock TAY; Linke JIAN; Ping YANG; Sivakumer MANIAM; Sher-Yi CHIAM; Jeroen Anton van KAN</i> | 27 |
| A01245-02918 | A Novel Micro Multimirror System for Focusing X-Rays of a Synchrotron Radiation Source <i>Yaping REN; Herbert O. MOSER; Thomas OSIPOWICZ; Francis, Eng Hock TAY; Linke JIAN; Xiaojiang YU; Caozheng DIAO; Mohammed BAHOU</i> | 28 |
| A01248-02148 | Characterization of Heavily Doped Polysilicon Films for SiMEMS based Thermoelectric Power Generator <i>Jin XIE; Chengkuo LEE</i> | 28 |
| A01298-02263 | Single-cell Electroporation using Proton Beam Fabricated Biochips <i>Sureerat HOMHUAN; Hui Fang CUI; Binbin ZHANG; Fwu-Shan SHEU; Andrew A. BETTIOL; Frank WATT</i> | 29 |
| A01354-02363 | Computational Study of Nanoelectromechanical Device Using Bilayer Graphene Nanoribbon <i>Kai-Tak LAM; Vincent Chengkuo LEE; Gengchiau LIANG</i> | 29 |
| A01386-02415 | A Wideband Electromagnetic Energy Harvester for Random Vibration Sources <i>Bin YANG; Chengkuo LEE</i> | 30 |
| A01386-02416 | Study of a Hybrid Energy Harvesting Mechanism Based on Piezoelectric and Electromagnetic Schemes <i>Bin YANG; Chengkuo LEE; Wei Loon KEE; Siak Piang LIM</i> | 30 |
| A01414-02452 | Designing High Frequency Microelectromechanical Resonators under Fabrication Uncertainty Using Methamodeling <i>Amir HEIDARI; Haejin CHOI; Jianmin MIAO</i> | 31 |
| A01520-02651 | Enabling Low Temperature Copper Bonding With an Organic Monolayer <i>Xiao Fang ANG; Jun WEI; Zhong CHEN; Chee Cheong WONG</i> | 31 |
| A01585-02792 | Contact Resistance Measurements of SAMs-Assisted Copper Thermo-compression Bonded Joints <i>Jia LI; Xiao Fang ANG; Jun WEI; Chee Cheong WONG</i> | 31 |
| A01598-02779 | Lab-On-A-Chip Technology for Single Molecule Detection Using Quantum Dots, Embedded Optical Fibres & Microchannels <i>Sook Fun CHAN; Chammika UDALAGAMA; Sureerat HOMHUAN; Andrew A. BETTIOL; Frank WATT; Thorsten WOHLAND</i> | 31 |
| A01665-02952 | DC-biased AC-electrokinetic Mixing: A Mechanistic Investigation <i>Wee Yang NG; Isabel RODRIGUEZ; Yee Cheong LAM</i> | 32 |
| A01768-03147 | Manufacturing Issues and Considerations in the Thermal Bonding of Polymer Based Lab-on-a-chip <i>Sum Huan NG; Yuxin KOH; Zhiping WANG</i> | 32 |
| A01783-03870 | Joining-up Single-Walled Carbon Nanotubes by Ag Nanojunction <i>Guangxia SHEN; Yiqing LU; Shouwu GUO</i> | 33 |
| A01823-03265 | Analysis of the Coupled Error and Q-factor in Vibratory MEMS Gyroscope with Various Air Pressure Points <i>Wenwen ZHOU; Rong ZHANG; Zhiyong CHEN; Bin ZHOU</i> | 34 |
| A01863-03221 | Analysis of Novel Building Blocks for Photonic MEMS Using Deep 1D Photonic Crystals <i>Maurine MALAK; François DUPORT; Hong CAI; Bassam SAADANY; Pierre NICOLE; Jean-Luc POLLEUX; Frédéric MARTY; Stéphane FORMONT; Ai-Qun LIU; Tarik BOUROUINA</i> | 34 |
| A01932-03336 | Fabrication of Mass Loaded MRFM Cantilever with Integrated Tip and Ultra-Low Spring Constant <i>Xiaosong TANG; Simon RAST; Ernst MEYER; Sujeet K. SINHA; Sean O'SHEA</i> | 34 |
| A01939-03346 | Design and Fabrication of Novel Compliant Electrostatically Actuated Microvalves <i>Qing ZHANG; Nikola PEKAS; David JUNCKER</i> | 35 |
| A01975-03414 | Flexible Micro-structured Mold for UV Micro-casting of Polymeric Microdevices <i>Lip Pin YEO; Lu WANG; Zhiping WANG; Yee Cheong LAM</i> | 35 |

6 Symposium L - NEMS/MEMS Technology and Devices

| | | |
|--------------|--|----|
| A02000-03451 | Numerical Simulation of Stretchable and Foldable Silicon Integrated Circuits <i>Zhuangjian LIU; YongWei ZHUANG; Yonggang HUANG</i> | 36 |
| A02069-03587 | Transmission Properties of Physical Waves in Photonic/Phonon Crystals <i>Jiu Hui WU; H. L. CHEN; Boris LUK'YANCHUK; Ai.-Qun. LIU</i> | 36 |
| A02117-04461 | Kinetics Analysis of UV-Curable Epoxy Resins for Micromachining Applications <i>Feng Lin NG; Vanda Yu VOYTEKUNAS; Chai Ling KOH; Marc J. M. ABADIE</i> | 37 |
| A02247-03832 | Micro and Nano Patterning on Phase Change Materials <i>Luping SHI; Tow Chong CHONG; Eng Keong CHUA; Rong ZHAO; Ming Hui HONG; Gaoqiang YUAN; Jia Yin SZE</i> | 37 |
| A02349-04222 | Gray Scale Maskless Lithography for One Step Fabrication of 3-Dimensional Structures in SU-8 <i>Amritha RAMMOHAN; Prabhat DWIVEDI; Ashutosh SHARMA</i> | 38 |
| A02371-04058 | Study on Packing Experiment of Biodegradable Micro Drug Delivery System <i>Xiaopeng WANG; Tianning CHEN</i> | 38 |
| A02460-04197 | Fabrication of a Microfluidic Device with Locally Insulated Electrodes on both Top and Bottom Sides of the Channel <i>Lujun ZHANG; Andre BOSSCHE</i> | 38 |
| A02471-04256 | Microfluidic Devices Fabricated by LTCC Combined with Thick Film Lithography <i>Young Joon YOON; Jaekyung CHOI; Jong-woo LIM; Hyo Tae KIM; Jihoon KIM; Youn-Suk CHOI; Jong-Heun LEE; Jong-hee KIM</i> | 39 |
| A02551-04390 | A Release Mathematical Model and Manufacturing Process of a Novel Controlled Drug Delivery System with Micro-porous <i>Yang GAO; Tianning CHEN; Xiaopeng WANG</i> | 39 |
| A02577-04710 | All-Optical Signal Processing Based on Nonlinear Effects in Semiconductor Optical Amplifiers <i>Jian WU; Minxue WANG; Bingbing WU</i> | 40 |
| A02613-04466 | Micro/Nano Science Uncovering the Mysteries of Silicon Wet Etching for the Fabrication of MEMS Structures <i>Kazuo SATO; Mitsuhiro SHIKIDA; Miguel A. GOSALVEZ; Prem PAL</i> | 40 |
| A02621-04479 | Building a Lensless, High-resolution On-chip Microscope for \$10 <i>Changhuei YANG</i> | 40 |
| A02623-04490 | Bioelectronics – The Next Wave <i>Levent YOBAS</i> | 41 |
| A02646-04541 | Gas Permeation in PDMS (polydimethylsiloxane) in-situ Monitored by Silicon Pressure Sensors <i>Lung-Jieh YANG; Yu-Cheng OU</i> | 41 |
| A02648-04876 | MEMS Optical Switches <i>Ramya RAJU; SHANMUGAPRIYA</i> | 42 |
| A02667-04894 | Transfer Technology of Ferroelectric Films onto the Polymer Substrate for the Application of High Density Capacitor <i>Masaaki ICHIKI; Ryutaro MAEDA; Tadatomo SUGA</i> | 42 |
| A02687-04621 | Label-free Protein Detection via Gold Nanoparticles and Localized Surface Plasmon Resonance <i>Shaoli ZHU; Jingbo ZHANG; Lanry Yung Lin YUE; Dany HARTONO; Ai-Qun LIU</i> | 43 |
| A02687-04633 | A THz-wave Photonic MEMS Generator <i>Ji Fang TAO; Bing LIU; Wei Ming ZHU; Hong CAI; Jonathan TAMIL; Jian WU; Kun XU; Jin Tong LIN; Ai-Qun LIU</i> | 43 |
| A02704-04682 | A Photonic Mems Polarization Switch <i>Weiming ZHU; Wu ZHANG; Tarik BOUROUINA; Ai-Qun LIU</i> | 43 |
| A02704-04698 | MEMS Tunable De-multiplexer Using FTIR Ring Down Resonators <i>Weiming ZHU; Wu ZHANG; Tarik BOUROUINA; Ai-Qun LIU</i> | 44 |
| A02707-04655 | Development of Liquid Tunable Diffractive/Refractive Hybrid Lens Based on Combination of Diamond Turning and Soft Lithography <i>Hui Min LEUNG; Hongbin YU; Guangya ZHOU; A. SENTHIL KUMAR; Fook Siong CHAU</i> | 44 |
| A02708-04667 | Tunable Optical Filter by Thermal Effect Based on MEMS Technology <i>Wu ZHANG; Jifang TAO; Weiming ZHU; Hong CAI; Ai-Qun LIU</i> | 45 |

| | | |
|--------------|---|----|
| A02708-04675 | High Accuracy Pressure Sensor Based on Optical MEMS Technology <i>Wu ZHANG; Jifang TAO; Weiming ZHU; Ai-Qun LIU</i> | 45 |
| A02714-04672 | Step & Stamp Imprinting Microlithography Studies of Chemical and Topographical Signaling on Osteoblast Cells <i>Somjai SANGYUENYONGPIPAT; Ananda SAGARI; Mikko LAITINEN; Timo SAJAVAARAA; Harry WHITLOW; Paavo RAHKILA; Sulin CHENG; Tomi HATAINEN</i> | 45 |
| A02720-04677 | Thermal Management and Alignment Strategies in MEMS Tunable Laser Packaging <i>Jifang TAO; Jonathan TAMIL; Weiming ZHU; Jian WU; Kun XU; Jintong LIN; AiQun LIU</i> | 46 |
| A02738-04783 | Transport of Water and Biofluids in High Aspect Ratio Microfluidics Devices Lithographically Fabricated Using Proton Beam Writing (PBW) <i>Harry WHITLOW; Liping WANG; Leona GILBERT</i> | 46 |
| A02744-04716 | A Phase Shift Refractometer Based on Transmission Phase Grating Using Microfluidic Chip <i>Zhenguo LI; Bing LIU; Jingbo ZHANG; Ai-Qun LIU</i> | 47 |
| A02745-04717 | UV-visible Spectra Character of Larger Diameter of Gold Nanoparticles (AuNPs) <i>Shaoli ZHU; Jingbo ZHANG; Lanry Yung Lin YUE; Dany HARTONO; Ai-Qun LIU</i> | 47 |
| A02746-04718 | On-Chip Liquid Waveguide with Gold Nanoparticles Dispersion <i>Sha XIONG; Yi YANG; Ai-Qun LIU</i> | 48 |
| A02746-04787 | Liquid Prism with Tunable Transmission/Reflection <i>Sha XIONG; Yi YANG; Ai-Qun LIU</i> | 48 |
| A02749-04719 | An Integrated Fabry-Pérot Resonator using Liquid Tunable Microlenses <i>Lip Ket CHIN; Ai-Qun LIU</i> | 48 |
| A02749-04798 | An On-chip Michelson Interferometer Realized using Droplet Microfluidics <i>Lip Ket CHIN; Ai-Qun LIU</i> | 49 |
| A02750-04751 | The Design and Fabrication of Poly(dimethylsiloxane) Single Mode Rib Waveguides for Lab-on-a-chip Applications <i>Jack Sheng KEE; Daniel Puiu POENAR; Levent YOBAS</i> | 49 |
| A02761-04728 | Modeling of Micro-Fluidic Droplet Resonator Based on Whisper Gallery Mode <i>Bin DONG; Ye Feng YU; Ai-Qun LIU</i> | 50 |
| A02771-04736 | Investigation on the Optimization of the Micro-mixing Process using Nature's Golden Spiral Ratio <i>Yongjun WEE; Ai-Qun LIU</i> | 50 |
| A02775-04742 | Dynamic Liquid Optical Splitters and Interferometers Integrated into Micro-Fluidic-Systems <i>Yi YANG; Sha XIONG; Ai-Qun LIU</i> | 50 |
| A02775-04743 | A Liquid Optical Tip via Control of Diffusion Coefficient and Flow Rate <i>Yi YANG; Sha XIONG; Ai-Qun LIU</i> | 51 |
| A02776-04748 | Droplet-based Lattice as Diffraction Gratings for Cell Analysis <i>Jiaqing YU; Lip Ket CHIN; Ai-Qun LIU</i> | 51 |
| A02780-04753 | Bandstop Filters with Comb-like Electromagnetic Bandgap Structures on CPW Stubs <i>Zhongliang DENG; Jianming HUANG; Binghui DING</i> | 51 |
| A02781-04750 | Photothermal Technique for Materials Characterization and Live Cells Monitoring <i>George Chung Kit Chen CHEN; Srivathsan VASUDEVAN; Choon Kiat, Andass TEU; Balpreet Singh AHLUWALIA; Marta ANDIKA</i> | 52 |
| A02783-04754 | On-Chip Spherical Cavity for Fluorescence Emission Enhancement <i>Ye Feng YU; Tarik BOUROUINA; Ai-Qun LIU</i> | 52 |
| A02783-04789 | An On-Chip Micro-Droplet Optical Filter Using Evanescent Wave Coupling <i>Ye Feng YU; Tarik BOUROUINA; Ai-Qun LIU</i> | 52 |
| A02825-04840 | A Micro-Fluidic Cell Culture Array for On-Chip Virus Infection <i>Jingjing GU; Ai-Qun LIU</i> | 53 |
| A02832-04853 | A Micromachined Thermooptic Tunable Laser <i>Hong CAI; Weiming ZHU; Jifang TAO; Wu ZHANG; Qing Xin ZHANG; Ai-Qun LIU</i> | 53 |
| A02838-04860 | Flows in Micro-Channels and Cavities - Visco-Elastic, Faradaic Charging and Surface Roughness Effects <i>Yee Cheong LAM</i> | 53 |

| | | |
|--------------|--|----|
| A02850-04879 | Micromachining Pressure Sensors on Optical Fiber tip <i>Xuming ZHANG; Miao YU; Hyungdae BAE; Christian ALTMAYER; Ai Qun LIU</i> | 54 |
| A02886-04934 | Photothermal Imaging (PTI) System for the Imaging of Gold Nano-particles and Cellular Organelles <i>Chi Lok WONG; George C. K. CHEN; Teu Choon KIAT; Srivathsan VASUDEVAN; Pham Thuy ANH; Puhan Niladri BIHARI; Marta ANDIKA; Shu CHI; Lin ZHIPING; Peng CHEN</i> | 55 |
| A02892-04941 | S ³ Micromachine as Multi-scale Interface for BME <i>Satoshi KONISHI</i> | 55 |
| A02893-05065 | Metallic Nano Particles and Nano Structures for Bio-applications <i>Jingbo ZHANG; L. Y. L. YUNG; S. S. CHUA; J. Y. SZE; S. L. ZHU; T. C. AYI; R. JEEVANSWARAN</i> | 56 |
| A02946-05035 | In/Ex-situ Detection of HBV DNA Using Dynamic Microcantilever <i>Tae Song KIM</i> | 57 |
| A02948-05038 | Non-Negative Input Design Control Scheme to Solve “Pull-In” Instability of MEMS Parallel Plate Actuators <i>M. H. NIKPANAH; Youyi WANG; F. L. LEWIS; A. Q. LIU</i> | 57 |
| A02988-05107 | Capacitively Coupled Contactless Conductivity Detection with Dual Top-Bottom Cell Configuration for Microchip Electrophoresis <i>Kambiz Ansari MAHABADI; Isabel RODRIGUEZ; Liu HONG; Peter C. HAUSER; Nico F. DE ROOIJ</i> | 58 |

A00808-01418**Exploring the Innovational Biomimetics for Novel 3D MEMS Potential of**Ille C. GEBESHUBER^{1;2;3;},Herbert STACHELBERGER^{3;4;},Burhanuddin Yeop MAJLIS¹

1. IMEN, Institute of Microengineering and Nanoelectronics, Universiti Kebangsaan Malaysia, Bangi/Selangor, Malaysia

2. Institut für Allgemeine Physik & AC2T research GmbH, Austrian Center of Competence for Tribology, Vienna University of Technology, Vienna and Wiener Neustadt, Austria

3. TU BIONIK, Center of Excellence Bionik / Biomimetics, Vienna University of Technology, Vienna, Austria

4. Institute of Chemical Engineering & University Service-Center for Transmission Electron Microscopy, Vienna University of Technology, Vienna, Austria

For MEMS and NEMS technologies, macroscopic best practice in terms of, for example, lubrication and surface topography cannot be scaled down linearly. Effects of adhesion, stiction and contamination by third bodies, which are swamped by bulk continuum phenomena at the macroscale, become dominant at the micrometer length scale. Currently, the MEMS and NEMS industry puts great effort into investigating tribology on the micro- and nanometre scale. Novel three dimensional MEMS such as piezoelectric inkjet printer parts, accelerometers in cars for airbag deployment in collisions, gyroscopes used in modern cars to trigger dynamic stability control, disposable blood pressure sensors, or the several hundred thousands of digital micromirrors in a beamer would exhibit increased performance as soon as their tribology were optimized.

Diatoms are single-celled organisms that generally multiply by cell division. One of the best-known properties of the diatom cell is that it is contained in a shell of amorphous hydrated silica, SiO₂ . 2 H₂O. It is known from the fossil record that colony formation by means of rigid linking structures in relative motion has a long history in the diatoms: there are impressive examples of sister valves remaining attached through linking structures in fossil deposits as many as 50 million years old. Diatoms already have well adapted and elaborate tribological properties on the micro- and nanometer length scale and, therefore, can provide valuable ideas and templates for optimized MEMS and NEMS.

The BioScreen project analyses the rich flora in South East Asia concerning its biomimetic inspirational potential for technological applications. A central aspect in the implementation of the project is the cooperation between institutions in the European Union with local institutions in South East Asia. Increasing awareness about the technological innovation potential of the rainforest and its

abundance of species might cause a paradigm shift in the way locals view virgin forests. BioScreen is a pilot project with one major task: the installation of collaborations between key institutions that shall then serve as base for further projects.

In course of the BioScreen Project, diatoms and further organisms that are present in impressive species abundance in the tropical rainforest are thoroughly screened for their innovative potential for novel 3D MEMS. First results of the screening study will be presented.

A00858-01626**Compatibility Study of Diamond-like Nanocomposite Thin Films with Hydrazine Propellant for MEMS Microthruster**Pijus KUNDU¹; Ashesh RAY CHAUDHURI¹; Soumen DAS³; Tarun Kanti BHATTACHARYYA²

1. Advanced Technology Development Centre, Indian Institute of Technology Kharagpur; Kharagpur, India

2. E & ECE Department, Indian Institute of Technology Kharagpur; Kharagpur, India

3. School Medical Science and Technology, Indian Institute of Technology Kharagpur; Kharagpur, India

In microelectronics fabrication, the deposition of thin films has been a key processing step, because of their versatile applications in masking, isolation and passivation layers. With the advancement of technology for MEMS (Micro-Electro-Mechanical Systems) technology, further research for growth and development of thin film materials are need of the day for possible application in chemical, biological, micro-fluidic or inertial sensors or actuators. Pertaining to silicon MEMS based micro-thruster application it has been noted that silicon cannot tolerate very high internal pressure or heavy mechanical shocks. In case of silicon MEMS based micro propulsion system; physical and chemical compatibility of different propellants with silicon poses restriction on the choice of propellants in terms of unwarranted surface reaction.

For space applications, hydrazine is widely used as a propellant due to high specific heat and stability factors; on the other hand, hydrazine is a popular choice as an etching agent for silicon. In conventional metal body thruster where etching by hydrazine is not an issue, where as the direct contact of hydrazine in silicon MEMS thruster is a problem. Hence in order to develop a silicon MEMS microthruster it is necessary to study a protective passivation layers. Diamond like nano composite (DLN) thin film as a potential protective coating has been studied extensively in this work. A thorough investigation of etch rates of the DLN films deposited on silicon for various concentration of hydrazine (N₂H₄) at different temperatures and its chemical compatibility have been carried out and reported.

Author Index

| | | | | | |
|-----------------------------|----------------|-----------------------|--------|--------------------------------|----------------------------|
| A. BETTIOL, Andrew | 29 | DENG, Zhongliang | 51 | KURNIA, Jundika Candra | 24 |
| AB. RAHIM, Rosminazuin | 26 | DIAO, Caozheng | 28 | | |
| ABD AZIZ, Norazreen | 16 | DING, Binghui | 51 | LAI, Fukun | 17 |
| ABD. AZIZ, Norazreen | 24 | DONG, Bin | 50 | LAITINEN, Mikko | 45 |
| AHLUWALIA, Balpreet Singh | 52 | DUPORT, Fran ois | 34 | LAM, Kai-Tak | 29 |
| AKI, Atsushi | 14 | DWIVEDI, Prabhat | 38 | LAM, Khin Yong | 16, 17, 18, 20, 23 |
| AKI, Atushi | 10 | DZULKEFLI, Nur Azrina | 27 | LAM, Yee Cheong | 32, 35, 53 |
| ALI, Mohammad | 19 | | | LEE, Chengkuo | 28, 30 |
| ALTMEYER, Christian | 54 | FORMONT, St phane | 34 | LEE, Jong-Heun | 39 |
| ANDIKA, Marta | 52, 55 | | | LEE, Vincent Chengkuo | 29 |
| ANG, Xiao Fang | 31 | GANDHAM, Phanikumar | 11 | LEUNG, Hui Min | 44 |
| ANGELESCU, Dan | 15 | GAO, Yang | 39 | LEWIS, F. L. | 57 |
| ANH, Pham Thuy | 55 | GEBESHUBER, Ille C. | 22 | LI, Erping | 26 |
| AYATOLLAHI, Fatima Lina | 19 | GILBERT, Leona | 46 | LI, Hua | 16, 17, 18, 20, 23 |
| AYI, T. C. | 56 | GOSALVEZ, Miguel A. | 40 | LI, Jia | 31 |
| BAE, Hyungdae | 54 | GU, Jingjing | 53 | LI, Siao-Yi | 20 |
| BAHOU, Mohammed | 28 | GUO, Shouwu | 33 | LI, Zhenguo | 47 |
| BAIS, Badariah | 26, 27 | HAJAR, Nurul | 19 | LIANG, Gengchiau | 29 |
| BERTHET, Helene | 15 | HANAJIRI, Tatsuro | 10, 14 | LIM, Jong-woo | 39 |
| BETTIOL, Andrew A. | 18, 29, 31 | HARTONO, Dany | 43, 47 | LIM, Siak Piang | 30 |
| BHASKARAN, Madhu | 25 | HATAINEN, Tomi | 45 | LIN, Chia-Hui | 9 |
| BHATTACHARYYA, Tarun Kanti | 22 | HAUSER, Peter C. | 58 | LIN, Chih-Jer | 17 |
| BIHARI, Puhan Niladri | 55 | HEIDARI, Amir | 31 | LIN, Jin Tong | 43 |
| BIRGERSSON, Erik | 24 | HOI, Siew Kit | 18 | LIN, Jing-Chuen | 13 |
| BOSSCHE, Andre | 38 | HOMHUAN, Sureerat | 29, 31 | LIN, Jintong | 46 |
| BOUROUINA, Tarik | 34, 43, 44, 52 | HONG, Liu | 58 | LIU, Ai-Qun | 12, 34, 36, 43, 44, 45, 46 |
| BUYONG, Muhamad Ramdzan | 16, 24 | HONG, Ming Hui | 37 | 47, 48, 49, 50, 51, 52, 53, 54 | |
| CAI, Hong | 34, 43, 45, 53 | HSIEH, Chang-Yu | 13 | LIU, Bing | 43, 47 |
| CHAN, Sook Fun | 31 | HU, Ya-Zhen | 20 | LIU, Chun-Yu | 20 |
| CHAN, Tsung-Hsing | 14 | HUANG, Jianming | 51 | LIU, Hong | 23 |
| CHANG, Wei-Han | 12 | HUANG, Yonggang | 36 | LIU, Zhuangjian | 36 |
| CHAU, Fook Siong | 11, 44 | IANNUZZI, Davide | 9 | LO, Guo Qiang | 12 |
| CHEN, George C. K. | 55 | ICHIKI, Masaaki | 42 | LOMAS, Tanom | 12 |
| CHEN, George Chung Kit Chen | 52 | IRMAN, Khairul | 19 | LU, Yiqing | 33 |
| CHEN, H. L. | 36 | | | LUK'YANCHUK, Boris | 36 |
| CHEN, Peng | 55 | J. M. ABADIE, Marc | 37 | LUO, Rongmo | 16 |
| CHEN, Shu-Yin | 17 | JARUWONGRANGSEE, Kata | 12 | MA, Gang | 23 |
| CHEN, Tianning | 38, 39 | JEEVANSWARAN, R. | 56 | MAEDA, Ryutaro | 42 |
| CHEN, Zhiyong | 34 | JIAN, Linke | 27, 28 | MAEKAWA, Toru | 10, 14 |
| CHEN, Zhong | 31 | JIAO, Li Shi | 23 | MAHABADI, Kambiz Ansari | 58 |
| CHENG, Chiang-Ho | 14, 15 | JOHARI, Juliana | 25 | MAJLIS, Burhanuddin Yeop | 22 |
| CHENG, Sulin | 45 | JUNCKER, David | 35 | MALAK, Maurine | 34 |
| CHENNIAPPAN, Venkatesh | 10 | JUNDT, Jacques | 15 | MANIAM, Sivakumer | 27 |
| CHI, Shu | 55 | K. SINHA, Sujeet | 34 | MANIVEL, Raja | 11 |
| CHIAM, Sher-Yi | 27 | KAN, Jeroen Anton van | 27 | MARTY, Fr d ric | 15, 34 |
| CHIANG, Tsung-Hsing | 15 | KEE, Jack Sheng | 49 | MATUROS, Thitima | 12 |
| CHIANG, Wei-Ling | 9 | KEE, Wei Loon | 30 | MERCIER, Bruno | 15 |
| CHIN, Lip Ket | 48, 49, 51 | KHOO, Eng Huat | 26 | MEYER, Ernst | 34 |
| CHOI, Haejin | 31 | KIAT, Teu Choon | 55 | MEYER, Ernst | 34 |
| CHOI, Jaekyung | 39 | KIM, Hyo Tae | 39 | MOHEIMANI, Reza | 10 |
| CHOI, Youn-Suk | 39 | KIM, Jihoon | 39 | MOSER, Herbert O. | 27, 28 |
| CHONG, Tow Chong | 37 | KIM, Jong-hee | 39 | MUJUMDAR, Arun Sadashiv | 24 |
| CHUA, Eng Keong | 37 | KIM, Jung-Sik | 39 | MULAY, Shantanu | 20 |
| CHUA, S. S. | 56 | KIM, Tae Song | 21 | | |
| CUI, Hui Fang | 29 | KOH, Chai Ling | 57 | NAKAJIMA, Yoshikata | 10, 14 |
| DAMGHANIAN, Mitra | 18 | KOH, Yuxin | 37 | NG, Eddie Yin Kwee | 23 |
| DAS, Soumen | 22 | KONISHI, Satoshi | 32 | NG, Feng Lin | 37 |
| DE ROOIJ, Nico F. | 58 | KUNDU, Pijus | 55 | NG, Sum Huan | 32 |
| | | | 22 | NG, Teng Yong | 16, 23 |

| | | | | | |
|---------------------------------------|------------|-----------------------------|------------------------|-----------------------|--------------------|
| NG, Wee Yang | 32 | UDALAGAMA, Chammika | 18, 31 | ZHANG, Nan | 23 |
| NICOLE, Pierre | 34 | UKAI, Tomofumi | 10 | ZHANG, Qing | 35 |
| NIKPANAH, M. H. | 57 | VASUDEVAN, Srivathsan | 52, 55 | ZHANG, Qing Xin | 53 |
| NUMATA, Shinkichi | 14 | VOYTEKUNAS, Vanda Yu | 37 | ZHANG, Rong | 34 |
| OMAR, Aliff | 19 | WANG, Liping | 46 | ZHANG, Wu | 43, 44, 45, 53 |
| O'SHEA, Sean | 34 | WANG, Lu | 35 | ZHANG, Xuming | 54 |
| OSIPOWICZ, Thomas | 27, 28 | WANG, Minxue | 40 | ZHAO, Rong | 37 |
| OU, Yu-Cheng | 41 | WANG, Shouhua | 11 | ZHENG, Hong Yu | 23 |
| PAL, Prem | 40 | WANG, Xiaopeng | 38, 39 | ZHIPING, Lin | 55 |
| PEKAS, Nikola | 35 | WANG, Youyi | 57 | ZHOU, Bin | 34 |
| POENAR, Daniel Puiu | 49 | WANG, Zhiping | 32, 35 | ZHOU, Donna Xiao Dong | 23 |
| POLLEUX, Jean-Luc | 34 | WANICHAPICHART, Pikul | 12 | ZHOU, Guangya | 44 |
| QUAH, Lee Ching | 24 | WATT, Frank | 29, 31 | ZHOU, Wenwen | 34 |
| RAGHUPATRUNI, Venkata Satya Prasad | 11 | WEE, Lee Mein | 23 | ZHU, S. L. | 56 |
| RAHKILA, Paavo | 45 | WEE, Yongjun | 50 | ZHU, Shaoli | 43, 47 |
| RAJU, Ramya | 42 | WEI, Jun | 31 | ZHU, Wei Ming | 43 |
| RAMMOHAN, Amritha | 38 | WHITLOW, Harry | 45, 46 | ZHU, Weiming | 43, 44, 45, 46, 53 |
| RAST, Simon | 34 | WISITSORAAT, Anurat | 12 | ZHUANG, YongWei | 36 |
| RAY CHAUDHURI, Ashesh | 22 | WOHLAND, Thorsten | 31 | ZOU, Hua | 18 |
| REN, Yaping | 27, 28 | WONG, Chee Cheong | 31 | | |
| RO, Jeng-Jong | 12 | WONG, Chi Lok | 55 | | |
| RODRIGUEZ, Isabel | 32, 58 | WU, Bingbing | 40 | | |
| SAADANY, Bassam | 34 | WU, Cheng-Hsien | 20 | | |
| SAGARI, Ananda | 45 | WU, Hou-Jin | 9 | | |
| SAJAVAARAA, Timo | 45 | WU, Jian | 40, 43, 46 | | |
| SANGYUENYONGPIPAT, Somjai | 45 | WU, Jiu Hui | 36 | | |
| SAPPAT, Assawapong | 12 | XIE, Jin | 28 | | |
| SATO, Kazuo | 40 | XIONG, Sha | 48, 50, 51 | | |
| SENTHIL KUMAR, A. | 44 | XU, Kun | 43, 46 | | |
| SHANMUGAPRIYA | 42 | YAMASITA, Shigeru | 14 | | |
| SHARMA, Ashutosh | 38 | YANG, An-Shik | 12, 13, 14 | | |
| SHARMA, Jaibir | 21 | YANG, Bin | 30 | | |
| SHEN, Guangxia | 33 | YANG, Changhuei | 40 | | |
| SHEU, Fwu-Shan | 29 | YANG, Lung-Jieh | 41 | | |
| SHI, Luping | 37 | YANG, Ping | 27 | | |
| SHIAH, Zi Chao | 23 | YANG, Yi | 48, 50, 51 | | |
| SHIH, Chih-Hsin | 9 | YE, Ting | 17 | | |
| SHIKIDA, Mitsuhiro | 40 | YEOP MAJLIS, Burhanuddin | 18, 19, 24, 25, 26, 27 | | |
| SHOJI, Atsumu | 14 | YOBAS, Levent | 41, 49 | | |
| SINGH, Navab | 12 | YOON, Jin-Ho | 21 | | |
| SOW, Chorng Haur | 18 | YOON, Young Joon | 39 | | |
| SRIRAM, Sharath | 25 | YU, Hongbin | 11, 44 | | |
| STACHELBERGER, Herbert | 22 | YU, Jiaqing | 51 | | |
| STONE, Howard | 15 | YU, Miao | 54 | | |
| SUGA, Tadatomo | 42 | YU, Mingbin | 12 | | |
| SZE, J. Y. | 56 | YU, Xiaojiang | 28 | | |
| SZE, Jia Yin | 37 | YU, Ye Feng | 50, 52 | | |
| TAKAHASHI, Naohiro | 10 | YUAN, Gaoqiang | 37 | | |
| TAMIL, Jonathan | 43, 46 | YUCE, Mehmet | 10 | | |
| TANG, Xiaosong | 11, 34 | YUE, Lanry Yung Lin | 43, 47 | | |
| TAO, Ji Fang | 43 | YUE, Weisheng | 27 | | |
| TAO, Jifang | 45, 46, 53 | YUNAS, Jumril | 25 | | |
| TAY, Francis, Eng Hock | 27, 28 | YUNG, L. Y. L. | 56 | | |
| TEHRANIROKH, Masoomeh | 27 | ZAIYADI, Nazman | 16 | | |
| TEO, Selin H. G. | 12 | ZHANG, Binbin | 29 | | |
| TEU, Choon Kiat, Andass | 52 | ZHANG, Jingbo | 43, 47, 56 | | |
| TSENG, Li-Yu | 13, 14, 15 | ZHANG, Lujun | 38 | | |
| TUANTRANONT, Adisorn | 12 | | | | |